

FORM PTO-1449		Docket N. : 008 D-6836		Appl. No.: 09/170,625	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION			Applicant Duck-Kyun Choi		
(Use several sheets if necessary)			Filing Date: 10/13/98		Gr up Art Unit: 2813
U.S. PATENT DOCUMENTS					
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	FILING DATE IF APPROPRIATE
SA	5426064	6/20/1995	Zhang et al.		
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9	Kyung-Sub Song and Duck-Kyun Choi, "Electric Field Effect on the Metal Induced Crystallization of Amorphous Silicon," Proceedings of the Eighth International Symposium on Silicon-on Insulator Technology and Devices, Volume 97-23, pp. 75 - 80, 8/31/1997.				
	Seung-Ik Jun, Kyung-Sub Song, Sang-Hyun Park and Duck-Kyun Choi, "Fabrication of Low Temperature Poly-Silicon Thin Film Transistor Using Field Aided Lateral Crystallization (FALC)," The First Asian-European International Conference on Plasma Surface Engineering, October 5-9, 1997.				
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EXAMINER		DATE CONSIDERED			
[Signature]		5/25/00			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.					